

DMI-3006 (R1303)

Modified Polyimide based Negative type Photoresist

on silicon is generated through thermo-mechanical interactions of various organic materials with silicon during assembly process. The magnitude of warpage is effected by: 1) difference of the CTE between Si and resin. 2) modulus of resin. 3) processing & curing temperatures. Warpage increases as wafer diameter gets larger & wafer thickness gets thinner.

DMI-3006 is 'The super low-stress resin' for buffer layer and other organic layers. It shows much lower tensile modulus and much lower cure temperature than conventional resins (Table.1). DMI-3006 provides the benefits of a polyimide resin film without warpage (Fig.1). Other benefits of the material include very low moisture absorption, excellent electrical performance and enhanced adhesion to metals, especially copper. DMI-3006 can be used with a general photoresist process (Fig.2).

Table.1 Differentials compared with conventional resins

	Polymer type	Patterning process	Tensile Modulus (GPa)	Cure Temp. (°C)
Conventional A	PI Type	- ve	3.5	375
Conventional B	PBO type	+ ve	2.8	320
Conventional C	PI Type	+ ve	3.0	350
DMI-3006	Unique Polymer	- ve	0.1	UV Cured

DMI-3006 Features

- No Warpage due to Very Low Tensile Modulus
- Very High Electrical Reliability (Design of Low Moisture Absorption)
- UV Cured Low Thermal Requirements 3.
- Low Cure Shrinkage
- Good Storage Stability 5.
- High Heat Resistance
- **Good Electrical Properties**

(Dielectric Constant, Dielectric Dissipation Factor)

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Conventional resins



DMI-3006



Fig.1 Warpage comparison of 50um thick wafers with 10um films

Processing Guidelines

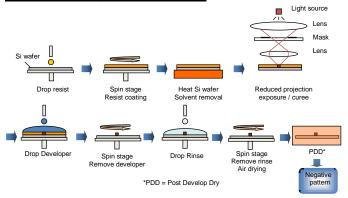


Fig.2 DMI-3006 Patterning Process

Coating

DMI-3006 is applied by the spin coating. DMI-3006 standard grade is adjusted to the viscosity of 200 - 250 mPa. Figures.3 shows the information of spin conditions to achieve the desired film thickness. Viscosity can be adjusted with solvent dilution. DMI-3006 can be applied in 5 to 20 um film thicknesses.

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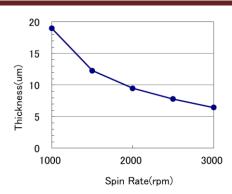


Fig.3 Spin speed vs Film Thickness

Pre-baking

A level hotplate with good thermal control and uniformity is recommended for use during the Pre-bake (solvent removal) step of the process. The recommended settings: 100 °C, 3 - 10 minutes.

Exposure

DMI-3006 is exposed with i-line (365nm). Fig.4 shows the photosensitive curve using high-pressure mercury vapor lamp. The exposure energy required for patterning is > 500 mJ/cm².

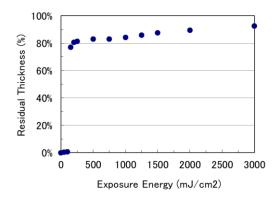


Fig.4 Photosensitive Curve

Development & Rinse

DMI-3006 is designed for spray-puddle, and any other developing equipment. The recommended developer is **R1247** which consists of organic solvents. The simple & recommended process is developing on a wafer with a spin coating as shown below.

- a) Drop R1247 on the wafer after exposure processing
- b) Developing (23 °C, 70 rpm, 40 sec. + 2000rpm, 10 sec.)
- c) Rinse (23 °C, 70 rpm, 10 sec. + 2000 rpm, 15 sec.)
- d) Drying

Post Develop Dry (PDD

A PDD temperature of 175 °C and for a time of 60 minutes is typically

Physical Properties

	Condition	Unit	Value
Tensile Strength	Instron	PSI	1,180
Elongation at break	Instron	%	62
Tg	TMA	°C	54
Thermal Expansion, α1/α2	TMA	ppm/ºC	164/222
Dissipation Factor	IPC-TM-650	1.5 GHz	<0.001
Dielectric Constant	2.5.5.9	1.5 GHz	2.6
Modulus at 25°C	DMA	GPa	0.1
Decomposition Temp. (in air)	TGA	°C	446
5% Weight Loss Temp. (in air)	TGA	°C	358
Water Absorption	23°C immersion, 24 hours	%	0.1
Moisture Absorption	23°C, 50% RH, 24 hours	%	0.1

Packaging and Storage

Packaging container is a glass or plastic gallon bottles (net 3.8 kg) or glass or plastic quart bottles (net 0.9 kg). Keep in sealed original container away from oxidants, sparks and open flames. Refrigerate until use and bring to ambient temperature prior to use. Protect from light and heat. Empty container may contain harmful residue and vapors.

Handling Precautions

Refer to the current Safety Data Sheet (SDS) for detailed information prior to handling.

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